



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Robert J. SMALL

Confirmation No. 4672

Application No.: 10/802,780

Art Unit: 1746

Filed: March 18, 2004

Examiner:

For: **RESIDUE REMOVERS FOR
ELECTROHYDRODYNAMIC
CLEANING OF SEMICONDUCTORS**

Atty Docket No.: 060937-0178-US

STATUS INQUIRY

U.S. Patent and Trademark Office
Randolph Building – Customer Service Window
104 Dulany Street
Alexandria, Virginia 22314

Sir:

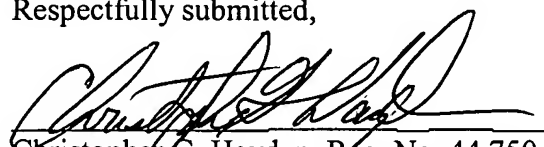
This application has been on file for two (2) years, and to date no substantive Action on the merits has been received. It is respectfully requested that an Action be issued, or an indication of when such Action may be issued.

No fee is believed to be due for this submission. Should any fees be required, however, please charge the required fees to Morgan, Lewis & Bockius LLP Deposit Account No. 50-0310.

Respectfully submitted,

May 1, 2006

By:


Christopher G. Hayden Reg. No. 44,750
MORGAN, LEWIS & BOCKIUS LLP
1111 Pennsylvania Avenue, N.W.
Washington, D.C. 20004
Tel: 202-739-3000
Fax: 202-739-3001